

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :
Naokatsu Ikegami : Group Art Unit: 1765
Application No. 10/698,546 : Examiner: Kin Chan Chen
Filed: November 3, 2003 :

For: METHOD OF DRY ETCHING ORGANIC SOG FILM

**AMENDMENT ACCOMPANYING REQUEST
FOR CONTINUED EXAMINATION**

U.S. Patent and Trademark Office
E-Filing
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:

In response to the Office Action dated February 13, 2009, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.